




DOCKET NO: VSEA 26-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther
Serial No: 10/006,462
Confirmation No: 5689
Filed: December 4, 2001
For: DOSE UNIFORMITY CONTROL FOR PLASMA DOPING
SYSTEMS
Examiner: Michelle Crowell
Art Unit: 1763

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 4th day of August, 2006.



Janine Canillas

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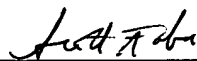
Sir:

Transmitted herewith are the following documents:

- ☒ Amendment
- ☒ Petition for Extension of Time
- ☒ Request for Continued Examination (RCE)
- ☒ Return Receipt Postcard

If any additional fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited. A duplicate of this sheet is enclosed.

Respectfully submitted,
Steven R. Walther, Applicant

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